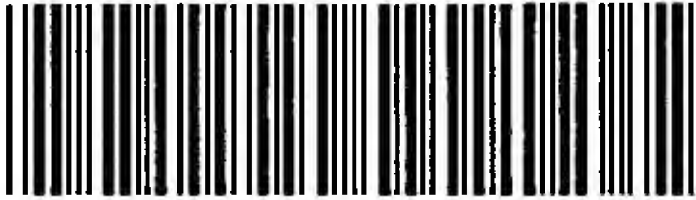


<b>Search Notes</b> 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	09/854,463	HANNUKSELA ET AL.	
	Examiner	Art Unit	
	Erick Rekstad	2621	

SEARCHED			
Class	Subclass	Date	Examiner
375	240.27 240.01 240.13 240.25	7/2/04 5/27/05 11/14/05	ER
386	117	7/21/04 5/27/05	ER
382	232	7/21/04 5/27/05	ER
348	14.01	7/21/04 5/27/05	ER
348	14.02	7/21/04 5/27/05	ER

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
375	240.25	5/27/2005	ER
375	240.27	11/14/2005	ER

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
IEEE: error <and> concealment <and> video	5/27/2005	ER
IEEE, ACM Digital Library, CiteSeer, Optics Information Database search for (h.263 and supplemental enhancement)	11/14/2005	ER
keyword search	7/21/2004	ER
keyword search	5/27/2005	ER
keyword search	11/14/2005	ER
keyword search	9/1/2006	ER
keyword search	12/10/2006	ER